

Description

This invention relates to a thin film magnetic transducer for reading and writing digital data on a magnetic disc.

In the magnetic disc art, the need for increased data density has led to a reduction in the track width for recording and reading data, thereby reducing the magnitude of signals from the transducer. An additional requirement of thinner magnetic disc media for high density memory applications will tend to still further reduce the magnitude of these signals. It is also advantageous to have the transducer write efficiently with relatively low write currents.

One way of generating additional signal amplitude and writing with low current is to add additional turns to the winding disposed between the pole pieces of a thin film transducer. The addition of more windings, however, has limitations. The transducer efficiency is controlled, in part, by the length of the region between the pole piece back gap region and pole tip region. As the distance between these two regions increases to make room for additional winding turns, a decrease in efficiency occurs.

One solution to the need for reading and writing efficiently with thin film transducers is described in the article entitled "Fabrication of Eight Turn Multi-Track Thin Film Heads", IEEE Transactions on Magnetics, Volume Mag 15, Number 6, November 1979, pages 1616 through 1618. The article describes a magnetic head which employs a plurality of windings, each stacked in parallel layers separated by a corresponding number of insulation layers. Such multiple insulation layers and conductor layers provide for steep transition regions connecting the back gap and pole tip portions of the magnetic transducers. This geometry imposes additional difficulty on conventional deposition techniques which are preferably carried out with more gradual transitions between the pole tip and back gap regions of the transducer element. With the structure described in this reference, the existence of numerous insulation layers poses a considerable risk of shorting the windings to an adjacent pole piece.

The article entitled 'Design Considerations for the DASTEK 4830 Disk Drive', IEEE Transactions on Magnetics, Volume MAG 17, Number 4, July 1981, page 1384, shows a thin film head in which windings are arranged in two layers to reduce the distance from the pole piece back gap region and the pole tip region. Each of the layers has a different number of windings from the other. This is reflected in the preamble of Claim 1.

US-A-4 318 148 discloses a thin film magnetic transducer including lower and upper magnetic lay-

ers forming a magnetic circuit loop containing a transducing gap and a back gap closure, the upper magnetic layer having end portions which slope down towards the lower magnetic layer adjacent the transducing gap and adjacent the back gap closure, lower and upper planar multi-turn conductive windings which are parallel, insulated from one another and from the magnetic layers, and with each turn passing through the magnetic circuit loop.

In accordance with the present invention a thin film magnetic transducer comprises first and second magnetic layers forming a magnetic circuit loop containing a gap closure and a transducing gap, said second magnetic layer having end portions sloping towards said gap closure and said transducing gap, the first magnetic layer deposited on a substrate before the second magnetic layer; first and second multi-turn conductive windings adjacent the first and second magnetic layers respectively, said windings being parallel to each other and insulated from each other and from said magnetic layers, and with each turn passing through said magnetic circuit loop and is characterised in that said first and second windings have the same number of turns as each other and in that the centre-to-centre spacing between the turns of said second winding is less than the centre-to-centre spacing between the turns of said first winding.

In providing a magnetic transducer having additional turns, it is advantageous that a centre tapped structure be provided which will permit half the turns to be used during a writing sequence, and to use all the turns in a sensing mode during a data read operation. Ideally, writing should be possible using either half of the winding in a centre tapped structure, without a different drive circuit for each winding half. In order to achieve this flexibility, each winding half of a centre tapped structure should have the equivalent impedance, in both inductive and resistive components.

The requirement for equal resistance between winding portions has been recognised in US-A-4 318 148.

In a preferred embodiment of the invention, each winding has the same number of turns and is joined at a common connection providing a centre tapped winding. The centre to centre spacing of the turns of the second winding is slightly different from the centre to centre spacing of the turns of the first winding. This permits the individual windings to be equally spaced from the pole piece transition regions which converge to form the pole tip region and back gap structure. The equally spaced windings permit the transition regions to have a lesser slope conducive to conventional deposition techniques without increasing the risks of a short circuit condition with the adjacent pole piece

transition region.

How the invention can be carried out will now be described by way of example, with reference to the accompanying drawings, in which:-

Figure 1 represents a top plan of a thin film magnetic transducer embodying the invention;

Figure 2A is a section on line 2A-2A of Figure 1 in the pole tip region; and

Figure 2B is a section on line 2B-2B of Figure 1, showing the centre tap connections of the thin film transducer.

Referring now generally to Figures 1 and 2A, a thin film magnetic transducer has a pole tip region P which abuts against an air bearing surface for reading and writing digital data on a magnetic disc carrier. The pole tip region P provides a magnetic transducing gap defined by a non-magnetic spacing 13 which may be an insulating material such as aluminium oxide. On one side of the non-magnetic spacing 13 is a first magnetic pole piece 12 and on the other side a second magnetic pole piece 11. As is known in the process of making thin film transducers, these various layers are deposited on a substrate 10, the substrate 10 generally holding a plurality of such thin film transducers made through deposition processes.

During the deposition processes of manufacturing thin film magnetic transducers, the first pole piece 12 is deposited on substrate 10. In the pole tip region P, the pole piece is seen to have a width of W which is slightly less than or equal to the width of a track of the magnetic disc carrier. The pole piece 12, generally comprising a layer of nickel-iron NiFe material extends rearwards and beyond the pole tip region, diverging laterally at an angle ϕ . A back gap closure 19 is positioned at the rearmost portion of the pole piece 12 which completes the magnetic circuit for pole pieces 11 and

The transducer gap non-magnetic material 13 is next deposited over the entire surface of the pole piece 12 when the material 13 is an insulator, in that region between the air bearing transducing surface and the back gap closure 19 region of the thin film transducer. However, the extent of material 13 must be more closely controlled when the material 13 is conductive, to avoid shorting the turns of the winding to be described below.

A first insulation layer 15 of baked photoresist, for instance, is deposited over the magnetic transducing gap layer 13. This layer 15 supports a plurality of segments of a single, continuous winding 17. The insulation layer 15 has in the pole tip region a generally sloping termination portion, the front edge of which defines one end of the transducer throat height. The remaining end of the throat height is defined by the ABS air bearing surface at the end of the pole piece. The winding

17, the first of two windings, comprises in the preferred embodiment, twelve turns which begin at an exterior connection point 17a, and continue spirally wound counter clockwise on the insulation layer 15 to a centrally located connection point 17b. The winding turns 17 which traverse the region between the pole tip and magnetic back closure area are shown to be generally transverse to the axis of the pole piece ends. The turns or segments of winding 17 between pole pieces 11 and 12 are equally spaced, having a centre line to centre line spacing of D2. Additionally, each edge of the exterior segments of winding 17 in the pole tip region is spaced away from the remaining pole piece 11. The winding 17 can be formed by depositing an electrically conductive material such as copper.

A second insulation layer 18, which also could be of baked photoresist, is deposited over the continuous winding 17, and has at the regions of the back gap closure and pole tip region, a similarly sloping geometry. The insulation layer 18 forms a support basis for yet another twelve turn spiral winding 20 having a centrally located winding end 20b positioned over the winding end 17b, see Figure 2B. As can be seen in Figure 2A, winding 20 includes a plurality of spiral clockwise segments having a centre line to centre line spacing D1 smaller than the first winding 17. Additionally, there is a corresponding reduction in the width W1 of each conductor of the second winding compared with the width W2 of each conductor of the first winding. The winding 20 may also be made of copper or any other suitable electrically conductive material. A final insulation layer 21, which again could be baked photoresist, is deposited over the conductor winding 20, having the sloping geometry at the pole tip and back gap closure 19. The resulting pair of windings 17 and 20 each have correspondingly deposited first end connection portions 20a and 17a which are accessible at the edge of the substrate 10.

A final deposition process step deposits a layer 11 of NiFe material which forms the remaining pole piece for the magnetic thin film transducer. The second pole piece 11 includes first and second transition regions 11a and 11b at the pole piece tip region, and similar transition regions 11d and 11e at the back gap region which traverse the multiple layers of insulation and conductor windings formed in the thin film transducer. The addition of only a single twelve turn winding provides for a sloping geometry for this transition region which does not create high risks of shorting the end turns of windings 17 and 20 with the deposited pole piece transition regions 11a, 11b, 11d and 11e.

The back portion of the transducer winding conductor segments which join with the conductor

segments 17 and 20 in the pole tip region are shown more particularly in Figure 2B. Rearward of the back gap closure 19 is shown a centre tap connection which includes conductor ends 20b and 17b and conductor 24. Conductor 24 is generally deposited at the same time as pole piece 11 and therefore is made of NiFe which is also an electrically conductive material. These individual conductor segments of windings 17 and 20 outside of the pole tip region are shown having a common spacing and width since the inductance of the winding is determined principally by those conductor segments of the windings in the pole tip region.

Winding end 20b includes an integral foot member 20c which is deposited through a mask to contact winding end 27b. Conductor 24 also is shown having an integral foot member 24b contacting winding end 20b. Thus, conductor 24 provides a centre tap connection to the ends of windings 17 and 20. Insulation layers 15, 18 and 21 are deposited at the same time the corresponding insulation layers in the pole tip region are deposited to maintain the windings from contacting each other beyond the centre tap connection.

The windings 17 and 20 provide a continuous single direction current path. Thus, on reading, the magnetic transitions on the disc are sensed by the pole pieces 11 and 12 which induce a voltage across the windings 17 and 20. This voltage can be measured at the winding ends 17a and 20a. The windings 17 and 20 are wound in the same sense, that is, as shown in Figure 2A, the conductor coil starts at the winding end 20a, proceeds in a clockwise spiral direction through winding 20 around the back gap closure 19, ends the spiral at the conductor end 20b and continues through the integral foot member 20c into the conductor end 17b into the winding 17 which proceeds in a clockwise expanding spiral direction to the winding end 17a. It should be understood that the direction of the winding is arbitrary and can be considered to be counterclockwise if the direction starts at the winding end 17a with either the winding 20 being deposited on top of the winding 17 or the winding 20 being deposited on top of the winding 17 or the winding 17 being deposited on top of the winding 20. The windings 17 and 20 are wound in the same sense so that the voltage induced in each are added to produce the total output voltage, and not subtracted which would effectively cancel the outputs.

By selecting the distances D1, D2 and widths W1, W2, in the magnetic circuit as shown in Figure 2A, it is possible to maintain the windings from risk of electrically shorting with the pole piece layer 11. Additionally, the change in spacing between windings 20 and 17 does not alter the inductance of the windings to any appreciable extent. In the pre-

ferred embodiment, the centre line to centre line spacing of 2 of the turns of winding 17 is selected to be approximately 8 microns, and the centre line to centre line spacing D1 of the coil member 20 is selected to be approximately 7.5 microns. The effect of the narrower spacing for conductor winding 20 is to draw the conductor 20' nearest the air bearing surface and nearest the back gap closure inward approximately 3 microns, relative to the corresponding first layer turns of winding 17. This spaces the conductor 20' nearest the air bearing surface and the back gap closure the same distance from region 11a and 11d, as the corresponding conductors of winding 17. The inductance associated with each turn of each winding is determined only by the distance of the turn from the back gap closure. Thus, by maintaining the average distance from the back gap closure for each turn of the two windings the same, the inductance of each of the coils may be maintained substantially the same. The resistance of each of the two windings can be maintained by plating thickness control during the deposition of each winding. Thus, it is possible to maintain the electrical characteristics of each winding substantially the same.

With the foregoing two-winding structure, it is possible to provide a write mode for the transducer, using one winding of twelve turns, and to read using the combination of windings for the full twenty-four turns. By utilising a single winding for writing, it is possible to be provided a low impedance drive for a write circuit. Additionally, with the inductance and resistance substantially the same in each coil structure, it is possible to select either winding for writing without any corresponding changes to the write circuit.

An additional advantage of the two-winding structure is that a differential read circuit can be employed, where the two windings are serially connected, using the centre tap as a common connection, and differential measurements of flux change are made when data is read from the magnetic storage medium. There is, as is known to those skilled in the art, an improved noise rejection when making differential measurements with respect to a common connection.

Although the preferred embodiment has two windings of twelve turns each, other numbers of turns can be used. The structure provides an increased flux without a corresponding reduction in the efficiency of the thin film transducer element which accompanies the lengthening of the distance from the pole tip to the back gap structure. The advantageous spacing of the windings of each conductor layer with respect to the remaining conductor layer permits efficiency to be maintained while avoiding any difficult steep sloping geometries.

The added separation between the exterior

NiFe layers of the pole pieces, as is necessary to accommodate the insulation layers and conductor winding of the upper winding, decreases the leakage between the pole pieces, thus tending to concentrate the magnetic flux in the pole tip region, the region of interest. The reduction of flux leakage also improves the efficiency of the transducer.

Claims

1. A thin film magnetic transducer comprising:
first (12) and second (11) magnetic layers forming a magnetic circuit loop containing a gap closure (19) and a transducing gap (13), said first magnetic layer having end portions sloping towards said gap closure and said transducing gap, the first magnetic layer deposited on a substrate before the second magnetic layer;
first and second multi-turn conductive windings (17, 20), adjacent the first and second magnetic layers respectively, said windings being parallel to each other and insulated from each other and from said magnetic layers, and with each turn passing through said magnetic circuit loop,
characterised in that said first and second windings have the same number of turns as each other and in that
the centre-to-centre spacing between the turns of said second winding is less than the centre-to-centre spacing between the turns of said first winding.
2. A thin film magnetic transducer as claimed in claim 1 wherein said second winding is formed by a conductor having a narrower width than a conductor forming said first winding.
3. A thin film magnetic transducer as claimed in either claim 1 or claim 2 further comprising means for connecting an end of said first winding to an end of said second winding to form a centre-tapped winding arrangement.
4. A thin film magnetic transducer as claimed in any of the preceding claims wherein said first and second windings are wound in the same sense.
5. A thin film magnetic transducer as claimed in any of the preceding claims wherein said first and second windings have substantially the same resistance as each other.
6. A thin film magnetic transducer as claimed in any of the preceding claims wherein said first and second windings have substantially the

same inductance as each other.

7. A thin film magnetic transducer as claimed in any of the preceding claims wherein each of said windings has at least twelve turns.

Patentansprüche

1. Magnetischer Dünnschichtwandler, der folgendes aufweist:
eine erste (12) und eine zweite (11) magnetische Schicht, die eine Schleife für einen magnetischen Kreis bilden, die eine Spaltverbindung (19) und einen Wandlerspalt (13) enthält, wobei die erste magnetische Schicht Endabschnitte aufweist, die in Richtung der Spaltverbindung und des Wandlerspaltes geneigt sind und die erste magnetische Schicht vor der zweiten magnetischen Schicht auf einem Träger aufgebracht ist,
eine erste und eine zweite leitende Mehrwindungswicklung (17, 20) die benachbart zu der ersten beziehungsweise zweiten magnetischen Schicht liegen, wobei die Wicklungen parallel zueinander liegen und voneinander und von den magnetischen Schichten isoliert sind und jede Windung die Schleife für einen magnetischen Kreis durchquert,
dadurch gekennzeichnet, daß die erste und die zweite Wicklung dieselbe Windungszahl aufweisen und daß
der Abstand zwischen den Mittelpunkten der Windungen der zweiten Wicklung kleiner als der Abstand zwischen den Mittelpunkten der Windungen der ersten Wicklung ist.
2. Magnetischer Dünnschichtwandler nach Anspruch 1, bei welchem die zweite Wicklung von einem Leiter gebildet wird, der schmaler ist, als ein Leiter, welcher die erste Wicklung bildet.
3. Magnetischer Dünnschichtwandler entweder nach Anspruch 1 oder nach Anspruch 2, der ferner Mittel aufweist, um ein Ende der ersten Wicklung mit einem Ende der zweiten Wicklung zu verbinden, damit eine Wicklungsanordnung mit einer Mittenanzapfung gebildet wird.
4. Magnetischer Dünnschichtwandler nach irgend einem der vorgehenden Ansprüche, bei welchem die erste und die zweite Wicklung in dieselbe Richtung gewickelt sind.
5. Magnetischer Dünnschichtwandler nach irgend einem der vorgehenden Ansprüche, bei welchem die erste und die zweite Wicklung im wesentlichen denselben Widerstand besitzen.



NiFe layers of the pole pieces, as is necessary to accommodate the insulation layers and conductor winding of the upper winding, decreases the leakage between the pole pieces, thus tending to concentrate the magnetic flux in the pole tip region, the region of interest. The reduction of flux leakage also improves the efficiency of the transducer.

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 - characterised in that said first and second windings have the same number of turns as each other and in that
 - the centre-to-centre spacing between the turns of said second winding is less than the centre-to-centre spacing between the turns of said first winding.
2. A thin film magnetic transducer as claimed in claim 1 wherein said second winding is formed by a conductor having a narrower width than a conductor forming said first winding.
3. A thin film magnetic transducer as claimed in either claim 1 or claim 2 further comprising means for connecting an end of said first winding to an end of said second winding to form a centre-tapped winding arrangement.
4. A thin film magnetic transducer as claimed in any of the preceding claims wherein said first and second windings are wound in the same sense.
5. A thin film magnetic transducer as claimed in any of the preceding claims wherein said first and second windings have substantially the same resistance as each other.
6. A thin film magnetic transducer as claimed in any of the preceding claims wherein said first and second windings have substantially the

same inductance as each other.

7. A thin film magnetic transducer as claimed in any of the preceding claims wherein each of said windings has at least twelve turns.

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 - eine erste und eine zweite leitende Mehrwindungswicklung (17, 20) die benachbart zu der ersten beziehungsweise zweiten magnetischen Schicht liegen, wobei die Wicklungen parallel zueinander liegen und voneinander und von den magnetischen Schichten isoliert sind und jede Windung die Schleife für einen magnetischen Kreis durchquert,
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5. Magnetischer Dünnschichtwandler nach irgend einem der vorgehenden Ansprüche, bei welchem die erste und die zweite Wicklung im wesentlichen denselben Widerstand besitzen.



6. Magnetischer Dünnschichtwandler nach irgend einem der vorgehenden Ansprüche, bei welchem die erste und die zweite Wicklung im wesentlichen dieselbe Inaktivität besitzen.
7. Magnetischer Dünnschichtwandler nach irgend einem der vorgehenden Ansprüche, bei welchem jede der Wicklungen zumindest zwölf Windungen aufweist.

Revendications

1. Transducteur magnétique à films minces comprenant :
 une première (12) et une deuxième (11) couches magnétiques formant une boucle de circuit magnétique qui contient une fermeture d'entrefer (19) et un entrefer de transduction (13), ladite première couche magnétique ayant des parties d'extrémité qui s'inclinent vers ladite fermeture d'entrefer et ledit entrefer de transduction, la première couche magnétique étant déposée sur un substrat avant la deuxième couche magnétique ;
 un premier et un deuxième enroulements conducteurs multispères (17,20), adjacents à la première et à la deuxième couches magnétiques respectivement, lesdits enroulements étant mutuellement parallèles et isolés l'un de l'autre et desdites couches magnétiques, et chaque spire traversant ladite boucle de circuit magnétique, caractérisé en ce que
 lesdits premier et deuxième enroulements ont le même nombre de spires l'un que l'autre, et en ce que
 l'espacement de centre à centre entre les spires dudit deuxième enroulement est plus petit que l'espacement de centre à centre entre les spires dudit premier enroulement.
2. Transducteur magnétique à films minces suivant la revendication 1, dans lequel ledit deuxième enroulement est formé par un conducteur moins large qu'un conducteur formant ledit premier enroulement.
3. Transducteur magnétique à films magnétiques minces suivant la revendication 1 ou la revendication 2, comprenant en outre des moyens de connexion d'une extrémité dudit premier enroulement à une extrémité dudit deuxième enroulement, pour constituer un agencement d'enroulement à prise centrale.
4. Transducteur magnétique à films minces suivant l'une quelconque des revendications précédentes, dans lequel lesdits premier et deuxième enroulements sont enroulés dans le

même sens.

5. Transducteur magnétique à films minces suivant l'une quelconque des revendications précédentes, dans lequel lesdits premier et deuxième enroulements ont sensiblement chacun la même résistance.
6. Transducteur magnétique à films minces suivant l'une quelconque des revendications précédentes, dans lequel lesdits premier et deuxième enroulements ont chacun sensiblement la même inductance.
7. Transducteur magnétique à films minces suivant l'une quelconque des revendications précédentes, dans lequel chacun desdits enroulements comprend au moins douze spires.